IFW

Serial No. 10/649285

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PASENT APPLICATION

Mventor(s):

Avinoam Kornblit

Timofei Nikita Kroupenkine

Mary Louise Mandich Tobias Manuel Schneider Joseph Ashley Taylor

Donald Weiss Shu Yang

Case:

18-14-12-2-5-1-16

Serial No.:

10/649285

Filing Date:

August 27, 2003

Examiner:

Group Art Unit:

Title:

Method And Apparatus For Reducing Friction Between A Fluid And

A Body

COMMISSIONER FOR PATENTS

P.O. BOX 1450

ALEXANDRIA, VA 22313-1450

SIR:

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)

In accordance with 37 CFR 1.97(b), the enclosed Information Disclosure Statement, with attached reference(s), is submitted for consideration in the above-identified application.

Copies of the listed documents are enclosed together with the search report that listed these documents.

NO FEE IS REQUIRED

In the event of any non-payment or improper payment of a required fee, the Commissioner is authorized to charge or to credit **Lucent Technologies Deposit Account No. 12-2325** as required to correct the error.

nespectiony,

David W. Herring, Attor

Reg. No. 51069 908-582-4326

Date:

Docket Administrator (Room 3J-219)

Lucent Technologies Inc. 101 Crawfords Corner Road Holmdel, NJ 07733-3030

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on June 15, 2004.

Rose E. Ewald



PANFORMATION DISCLOSURE STATEMENT

Case Name. Serial No. Applicant: Filing Date:

Kornblit 18-14-12-2-5-1-16

10/649285 A. Kornblit, et al. August 27, 2003

Group:

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date
	AA	6,185,961	2/13/2001	Tonucci, et al.	65	60.4	1/27/1999
·	AB	US Pat. App. 10/798064		Arney, et al			3/11/2004
	AC	US Pat. App. 10/806543		Arney, et al			3/23/2004
	AD	US Pat. App. 10/816569		Gasparyan, et al.			4/1/2004
	AE	US Pat. App. 10/674448		Hodes, et al.			9/30/2003
	AF	US Pat. App. 10/803565	-	Hodes, et al.			3/18/2004
	AG	US Pat. App. 10/803641		Hodes, et al.			3/18/2004
	АН	US Pat. App. 10/403159		Kornblit, et al.			3/31/2003
	Al	US Pat. App. 10/649285		Kornblit, et al.			8/27/2003
	AJ	US Pat. App. 10/716084		Kroupenkine, et al.			11/18/2003
	AK	US Pat. App. 10/803576		Kroupenkine, et al.			3/18/2004
	AL	US Pat. App. 10/810774		Kroupenkine, et al.			3/26/2004

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation
					,	

OTHER (including Author, Title, Date, Pertinent Pages, etc.)

	Kim, et al., "Nanostructured Surfaces for Dramatic Reduction of Flow Resistance in Droplet-Based Microfluidics," IEEE, pp. 479-482 (2002).

^{***}References listed beyond AZ would list as AA-1, AB-2, AC-3 thru AZ-26.

EXAMINER	DATE CONSIDERED

^{***}Note First Page ONLY Header/Footer. Subsequent pages must ONLY have page # layout as header

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant